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PATENT NUMBER and  
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM 10043096	FILING DATE 01/14/2002	CLASS 361 629	SUBCLASS 234	GAU 3220	EXAMINER Harris, Anton
<b>**APPLICANTS:</b> Lee Sun-Young; <i>2836</i> <i>2831</i>					
<b>**CONTINUING DATA VERIFIED:</b> <i>OK</i>					
<b>** FOREIGN APPLICATIONS VERIFIED:</b> <i>OK</i> REPUBLIC OF KOREA 2001-29656 05/29/2001					
PG-PUB DO NOT PUBLISH <input type="checkbox"/>		RESCIND <input type="checkbox"/>			
Foreign priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no		35 USC 119 conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no		ATTORNEY DOCKET NO 242/115	
Verified and Acknowledged Examiners's initials <i>ABH</i>					
<b>TITLE :</b> Wafer space supporting apparatus installed on electrostatic chuck and method for fabricating the same <small>U.S. DEPT. OF COMM. PAT. &amp; TM. PTO-C35 (Rev. 12-99)</small>					

<b>NOTICE OF ALLOWANCE MAILED</b>		<b>CLAIMS ALLOWED</b>	
		Total Claims	Print Claim for O.G.
<b>ISSUE FEE</b>		<b>DRAWING</b>	
Amount Due	Date Paid	Sheets Drawg.	Figs. Drawg. Print Fig.
		Application Examiner	
<input type="checkbox"/> <b>TERMINAL DISCLAIMER</b>		<b>PREPARED FOR ISSUE</b> <b>WARNING:</b> The information disclosed herein may be restricted. Unauthorized disclosure may be prohibited by the United States Code Title 35, Sections 122, 181 and 368, Possession outside the U.S. Patent & Trademark Office is restricted to authorized employees and contractors only.	

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